



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG786681190
Report verification at igi.org

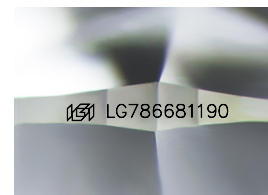
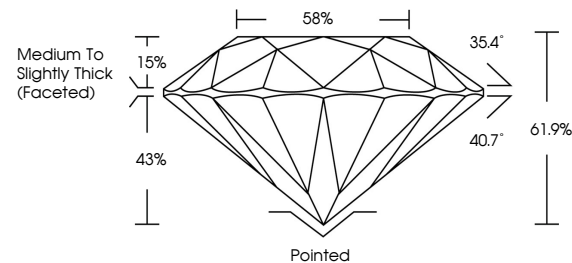
April 30, 2026	
IGI Report Number	LG786681190
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	10.90 - 10.93 X 6.76 MM
GRADING RESULTS	
Carat Weight	5.02 CARATS
Color Grade	G
Clarity Grade	VS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG786681190

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

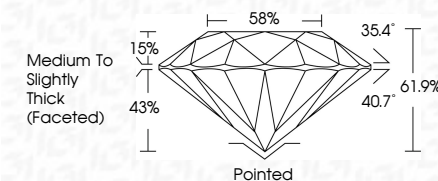
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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April 30, 2026
ICI Report No LG786681190
ROUND BRILLIANT

10.90 - 10.93 x 6.76 MM	Carat Weight	5.02 CARATS
	Color Grade	G
	Clarity Grade	VS 1
	Cut Grade	IDP AL
	Depth	61.9%
	Table	58%
	Girdle	Medium to Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Report #	1021678463100

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.